

TSMC-00-166



March 18, 2002

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To: Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572  
20 McIntosh Drive  
Poughkeepsie, N.Y. 12603

RECEIVED

OCT 23 2002

OFFICE OF PETITIONS

Subject: | Serial No. 09/679,514 10/06/00 |  
| Hung-Jen Hsu

"A METHOD TO IMPROVE PASSIVATION  
OPENINGS BY REFLOW OF PHOTORESIST  
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated December 20, 2001,  
please amend the above-identified application for patent as  
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first  
class mail in an envelope addressed to: Commissioner of  
Patent and Trademarks, Washington, D.C. 20231, on March 20,  
2002.

Stephen B. Ackerman Reg. No. 37,761

Signature

Date 3/20/02